

Response under 37 C.F.R. 1.116  
Expedited Procedure  
Examining Group (1792)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Hongqin Shi

Art Unit: 1792

Serial No.: 10/666,671 (8251)

Examiner: Vinh, Lan

Filed: 17 September 2003

Docket No. TI-62961

For: METHODS AND APPARATUS OF ETCH PROCESS CONTROL IN  
FABRICATIONS OF MICROSTRUCTURES

**RESPONSE UNDER 37 C.F.R. § 1.111**

10 August 2009

Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Dear Madam:

In response to the Examiner's Action dated 10 June 2009 applicant responds as follows: